



#4/Election
7/22/03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of :
Hiroyuki Kawano : Group Art Unit 2829
Serial No. 10/062,505 : Examiner Scott B Geyer
Filed February 5, 2002 :

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE INCLUDING ETCHING OF A
PERIPHERAL AREA BEFORE CHEMICAL-MECHANICAL POLISHING

RESPONSE TO ELECTION/RESTRICTION

U.S. Patent and Trademark Office
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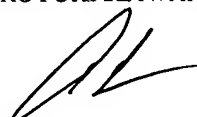
Sir:

In response to the Office Action dated May 30, 2002, Applicants elect the species
1, depicted by FIGS. 15-21 of the application. The election is without traverse. Claims
1, 2, 3, 4, 7, 8 and 11 are readable on the elected species, with Claims 1, 2 and 11 being
generic to all the species 1-4.

Respectfully submitted,

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By:


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